

#### **Isolation of Exosomes Using Viscoelastic Fluids in a Microfluidic Device**

DANIIL MIROSNIKOV



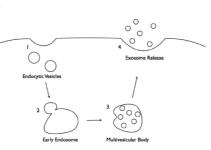
### Overview

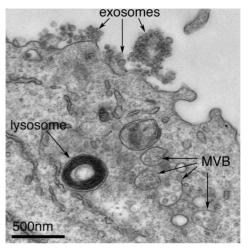
- Exosomes
- Exosome Isolation
- Viscoelasticity-based sorting
- Numerical Model
- Fabrication Process
- Conclusion



### Exosomes

- Extracellular vesicles
- 30 150 nm in diameter
- Secreted by most cells
- Abundantly found in most biological fluids
- Carry proteins, DNA's and RNA's
- Reflect origin cells
- Intercellular communication
- Neurodegenerative disorders
- AIDS
- Cancer





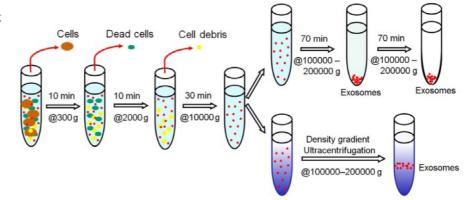
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# **Exosome Isolation**

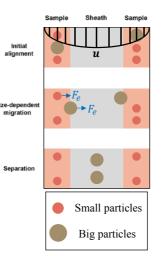
- Ultracentrifugation (current golden standard)
- $\notin$  40,000 80,000 for the ultracentrifuge
- €2,500 per annum running cost
- Dedicated specialists
- 4 5 hours per sample
- 5 25% yield

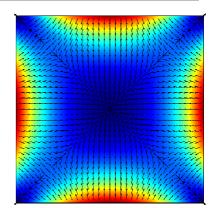




# Viscoelasticity-Based Sorting

- · Particle migration is always from the walls into the center of the microfluidic channel
- Continuous separation of particles
- No external devices
- No external fields
- No complex geometries





COMSOL simulation of the shear rate in a channel cross-section with elastic force vectors. Red colour represents regions of highest shear rate and dark blue colour represents regions of lowest shear rate.



#### Viscoelasticity-Based Sorting

The Convected Jeffrey (Oldroyd-B) Fluid Model

$$\rho\left(\frac{\partial u}{\partial t} + u \cdot \nabla u\right) = \nabla \cdot \sigma$$
  

$$\sigma = -pI + \tau$$
  

$$\tau = \eta_s \epsilon + \tau_p$$
  

$$\tau + \lambda_1 \hat{\tau} = -\eta_0 (\epsilon + \lambda_2 \hat{\epsilon})$$
  

$$\epsilon = (\nabla u) + (\nabla u)^T$$
  

$$\hat{\epsilon} = \frac{\partial}{\partial t} \epsilon + u \cdot \nabla \epsilon - \{(\nabla u)^T \cdot \epsilon + \epsilon \cdot (\nabla u)\}$$
  

$$\hat{\tau} = \frac{\partial}{\partial t} \tau + u \cdot \nabla \tau - \{(\nabla u)^T \cdot \tau + \tau \cdot (\nabla u)\}$$

 $\eta_0 = \eta_s + \eta_p$  (Water + Biocompatible polymer)  $\eta_p = 0.072 \eta_s c M_w^{0.65}$  $[\eta] = 0.72 M_w^{0.65}$  $\tau$  – Total Deviatoric Stress Tensor  $\epsilon$  – Strain-Rate Tensor  $\lambda_1 = 0.463 \frac{[\eta] M_w \eta_s}{N_A k_B T} \left(\frac{c}{c^*}\right)^{0.65}$ - Relaxation Time  $\lambda_2$  – Retardation Time  $\eta_0$  – Total Fluid Viscosity  $\eta_s$  – Solvent Viscosity  $\eta_p$  – Polymer Contribution to the Viscosity  $\lambda_2 = \frac{\eta_s}{\eta_0} \lambda_1 \qquad c^* = \frac{0.77}{[n]}$  $[\eta]$  – Intrinsic Viscosity  $M_w$  – Polymer Molecular Weight T-Temperature c – Concentration c\* - Critical Overlap Concentration  $N_A$  – Avogadro Number

- $k_B^{\text{A}}$  Boltzmann Constant (  $\hat{\ldots}$  ) Upper-Convected Time Derivative



## Viscoelasticity-Based Sorting

#### **Dominant Forces Acting on the Particles**

$$F_{p} = F_{D} + F_{V} + F_{e} \qquad \text{(Particle Force Balance)}$$

$$F_{e} = C_{e}d_{p}^{3}\nabla N_{1} \qquad \text{(Elastic Lift Force)} \qquad N_{1} = 2\eta_{p}\lambda_{1}\dot{\gamma}^{2}$$

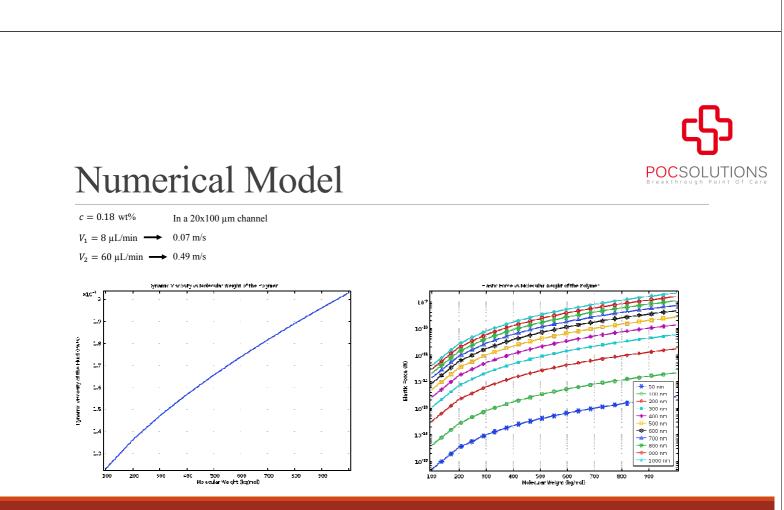
$$F_{V} = \frac{1}{12}\pi d_{p}^{3}\rho_{f}\frac{d(\boldsymbol{u} - \boldsymbol{V}_{p})}{dt} \qquad \text{(Virtual Mass Force)}$$

$$F_{D} = \frac{1}{\tau_{p}}m_{p}(\boldsymbol{u} - \boldsymbol{V}_{p}) \qquad \text{(Drag Force)} \qquad \tau_{p} = \frac{4\rho_{p}d_{p}^{2}}{3\eta C_{D}Re_{r}}$$

 $\begin{array}{l} \mathcal{C}_e - \text{Elastic Lift Coefficient} \\ \mathcal{d}_p - \text{Particle Diameter} \\ N_1 - \text{The First Normal Stress Difference} \\ \dot{\gamma} - \text{Shear Rate} \\ V_p - \text{Particle Velocity} \\ m_p - \text{Particle Mass} \\ \rho_f - \text{Fluid Density} \\ \rho_p - \text{Particle Density} \\ \mathcal{C}_D - \text{Drag Coefficient} \\ \mathcal{R}e_r - \text{Reynold's Number} \\ \langle : \rangle - \text{Contraction Operator} \end{array}$ 

 $\dot{\gamma} = \sqrt{2\epsilon \cdot \epsilon}$ 

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#### Numerical Model

c = 0.18 wt% $M_w = 600 \text{ kg/mol}$  $d_p = 100 \text{ nm}$  $V_1 = 8 \,\mu\text{L/min}$ 

 $V_2 = 60 \ \mu L/min$ 

c = 0.18 wt%

 $V_1 = 8 \,\mu\text{L/min}$ 

10

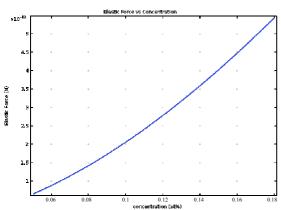
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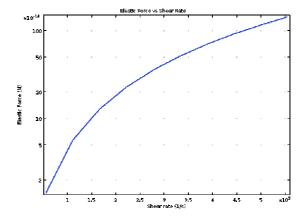
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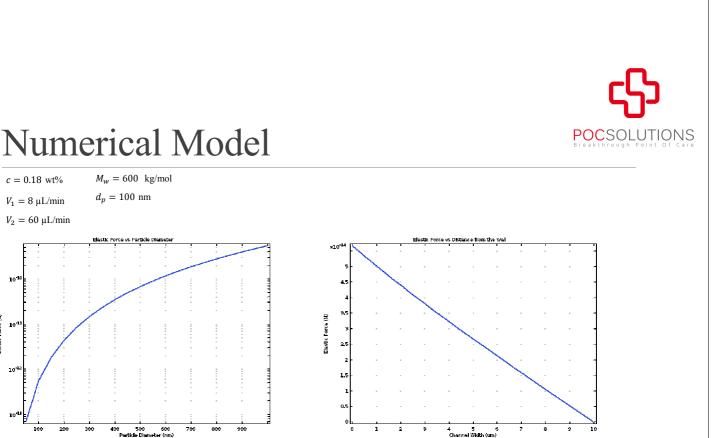
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100

Electic Force (N)

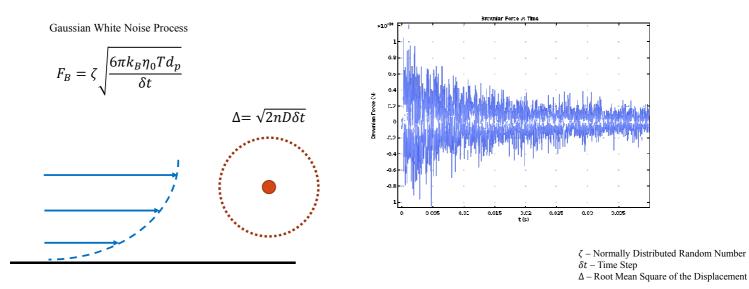






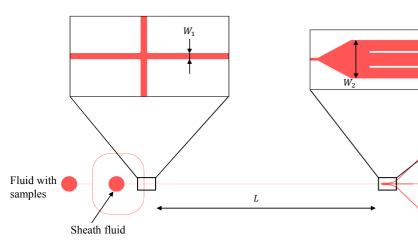


# Numerical Model





### Numerical Model



Microfluidic system geometry.

- By varying
- The channel length L
- Widths,  $W_1$  and  $W_2$
- Fluid speeds
- Rheological properties of the fluid

One can control the separation



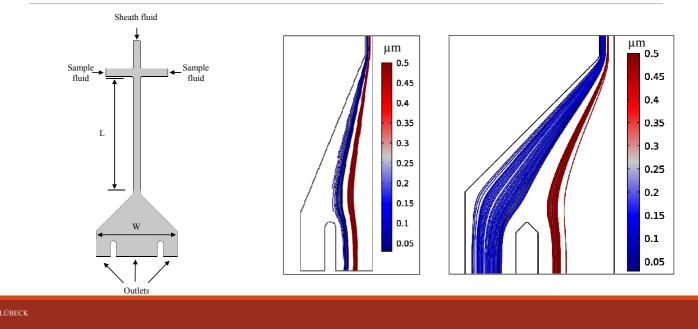
POCSOLUTIONS

Photoresist

Si

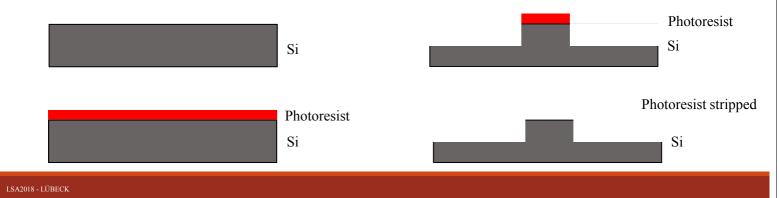
DRIE

## Numerical Model



# **Fabrication Process**

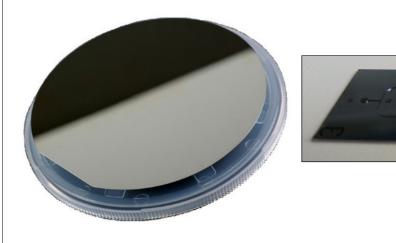
- Standard cleanroom fabrication
- Negative photoresist (nLOF) at 2 µm thickness
- Mask-less aligner (MLA) for the mask design
- $\bullet$  Dry Reactive Ion Etching (DRIE) at 100  $\mu m$  depth





POCSOLUTIONS

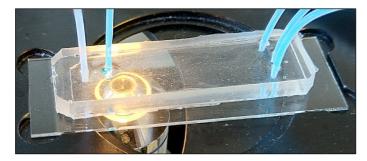
## **Fabrication Process**

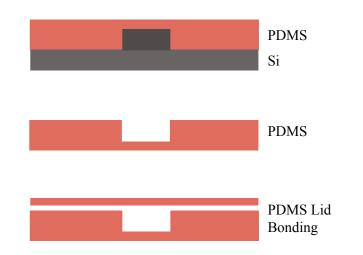


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## **Fabrication Process**

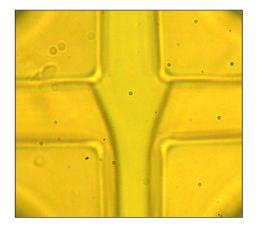
- PDMS (polydimethylsiloxane) + thermocurable polymer
- 3 hours in a 70°C oven

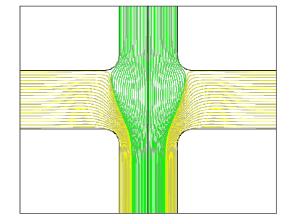






## **Fabrication Process**





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#### Conclusion

- High yield (~90%)
- High purity (~90%)
- Low price
- Low volume handling (~100  $\mu$ L)
- Short processing time (< 1 s)
- Simple design
- No material loss due to external fields
- Possibility to isolate other nanoparticles



# Thank you for your attention

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